PAGE 6/19 * RCVD AT 3/3/2004 3:44:09 PM [Eastern Standard Time] * SVR:USPTO EFXRF-1/1 * DMIS:8729319 * CSID:908 5/18 7795 * DURATION (mm-ss):09-16 ATTY DOCKET NO. GS.174.... 10/039,284 INFORMATION DISCLOSURE CITATION Richard A. Blanchard et al. (Use several sheets if necessary) GROUP FILING 2811 12/31/01 U.S. PATENT DOCUMENTS FILING DATE SUBCLASS CLASS NAME TEXAMINER DOCUMENT NUMBER DATE IF APPROPRIATE INITIAL 12/31/2001 Blanchard 10/039,241 12/31/2001 Blanchard 10/038,845 10/4/2001 Blanchard et al. 09/970,758 DU/ 438 138 12/20/2001 Deboy et al 2001/0053568A1 D270 438 11/1/2001 Hucting et al 2001/0036704A1 DC 268 438 10/4/2001 Hattori et al. 2001/0026977A1 493 257 6/1/93 Cheo 5,216,275 63 437 Tanigawa et al. 4/28/92 5,108,783 357 23.4 Blanchard 1/9/90 4,893,160 P 20 437 12/8/87 Lammert 4,711,017 10. FOREIGN PATENT DOCUMENTS TRANSLATION SUBCLASS CLAS8 COUNTRY DATE DOCUMENT NUMBER YES OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Xing Bi Chen et al., "A Novel High-Voltage Sustalaing Structure with Buried Oppositely Doped Regions," IEEE Transactions on Electron Devices, Vol. 47, No. 6, June 2000, pp. 1280-1285. R N. Cezac et al., "A New Generation of Power Unipolar Devices: the Concept of the FLoating Islands MOS Transistor (FLIMOST)," Proceedings of the 12th International Symposium on Power Semiconductor Devices & ICs, Toulouse, France, May 22-25, 2000, pp. 69-72. P^{C} DATE CONSIDERED 3/11/04 EXAMINER PHAT X. CAO EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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